

IFW

03500.017456

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KAZUHIRO KAGAMI ET AL.

Application No.: 10/627,645

Filed: July 28, 2003

For: BASE PATTERN FORMING
MATERIAL FOR ELECTRODE
AND WIRING MATERIAL
ABSORPTION, ELECTRODE
AND WIRING FORMING
METHOD, AND METHOD OF
MANUFACTURING IMAGE
FORMING APPARATUS

Examiner: H. M. Lee

Group Art Unit: 2823

March 1, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL AMENDMENT

Sir:

A. Introductory Comments

Further to the Amendment filed on February 27, 2006, please amend the application as follows and consider the following remarks.